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CONFIRMATION NO. 7618

SERIAL NUMBE 10/530,647	ER	FILING OR 371(c)	CLASS 369		GROUP ART UNIT 2655		ATTORNEY DOCKET NO. 2933HC-1		
APPLICANTS Tamaki Horisaka, Osaka, JAPAN; Koichi Suzuki, Osaka-shi, JAPAN; Akihide Minami, Osaka-shi, JAPAN; ** CONTINUING DATA ************************ This application is a 371 of PCT/JP03/16671 12/25/2003 ** FOREIGN APPLICATIONS ************************************									
Foreign Priority claimed 35 USC 119 (a-d) conditions yes no Met after Allowance Verified and Acknowledged Examiner's Signature Initials				STATE OR COUNTRY JAPAN	SHEETS DRAWING 3		TOTAL CLAIMS 20		INDEPENDENT CLAIMS 2
TITLE Method for producing glass substrate for information recording medium, polishing apparatus and glass substrate for information recording medium									
RECEIVED N	RECEIVED No to charge/credit DEPOSIT ACCOUNT					All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			